MI22-1544 09/677478 Sheet 1 of 1

Form PTO-1449			U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. MI22-1544		SERIAL NO. 09/677,478	
	LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			APPLICANT Blalock et al.			
				FILING DATE October 2, 2000		GROUP 1765	

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*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,533,953 B1 6533953	03/18/03	Allen, III Allen, III			
	AB	5,366,353 5566353	02/09/99	Chen et al. Chen et al			
	AC	5,865,938 5365938	02/02/99	Peeters et al. Peeters et al			
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	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	Stanley Wolf and Richard Tauber. Silicon Processing for the VLSI Era. Vol. 1, pp 549. 1986.
	AS	
	AT	

EXAMINER	DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.